WIPO ASIAN REGIONAL TRAINING COURSE FOR INTELLECTUAL PROPERTY TRAINERS AND INSTRUCTORS

organized by
the World Intellectual Property Organization (WIPO)

in cooperation with
the International Intellectual Property Training Institute (IIPITI)

and
the Korean Intellectual Property Office (KIPO)

and with the assistance of
the Japan Patent Office (JPO)

Daeduk, Daejeon, Republic of Korea, March 18 to 22, 2002

INTELLECTUAL PROPERTY (IP) TEACHING AND TRAINING
BY INTELLECTUAL PROPERTY INSTITUTIONS;
THE EXPERIENCE OF JAPAN

Document prepared by Mr. Koji Nishimori,
Patent Attorney,
AOI International Patent Firm, Tokyo
Japan Patent Attorneys Association
-Intellectual Property Training-

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Koji NISHIMORI
Japan Patent Attorneys Association Member

Patent System Triangle
What is the JPAA?

1. Board of Directors
   (The president and eight Vice-Presidents)
2. General Assembly (4,846 members)
3. Secretariat and its Staff
4. Main Office in Tokyo, Two Branches
5. Attached Organizations such as Arbitration Center, Training Institute, IP Assist and Support Center


1. Filing Applications with JPO and Proceeding Intermediate Procedures to Obtain IP Rights
2. Appealing to Tokyo High Court against Decisions by JPO Trial Examiners
3. Consultation on IP Matters under the Uniform Competition Law, Custom Tariff Law and Copyright Law
4. Co-Representing IP Infringement Suits before Court together with Attorney at Law (Soon)
JPAA Training Institute

1) Director, Assistant Director, and Several Administrative Divisions each consisting of necessary number of Staff

2) Holding of Variety of Training Courses
   - Distribution of Materials, Textbooks
   - Responding to Questions raised by Members
   - Publishing Magazines, Journals, Leaflets

3) Object of Training Courses:
   "To Maintain the Aptitude of Members and stay up to date with New Laws, etc."

Structure of Training Institute Committees

- Training Planning Division
- Orientation Training Division
- Member Training Division
- Compulsory Training Division
- Aptitude Training Division
- Ethics Training Division

Director and Assistant Director
Orientation Training Course

1) Held in Tokyo and Osaka (January to February)
3) 62 Topics (Textbooks and Content of Training Courses not Standardized)
4) Selection of Lecturers
5) Evaluation of Contents
6) Improvement of Training Course

Example I ("Preparing a Patent Application")

1) Lecture No.6 & 54 (January 16 & 22, 2002)
2) Not Compulsory
3) Each Lecture 9:30–12:30 (3 Hours)
4) Title: "Preparing a Patent Application"
5) Text: 25 Pages of Explanation and 73 Pages of Reference Material
6) Homework is given to Attendees in First Lesson and Correction is made to Each Specification Prepared
7) Lecturer: Keizo OKAMOTO; 17 years Experience as a Patent Attorney
8) Payment to Lecturer: $**** Including Two Days Lectures, Textbooks and Correction on Specifications made by Attendees
9) Not Evaluated by Third Parties
10) Can Improvement be Expected?
Member Training Course

1) General, Specific, Continuing, and Local
   2) General
      Theme: Topical Subjects such as "Patent Attorney and Copyright Practice", and "Legal Issues regarding Domain Names"
   3) Specific
      Theme: Basic Subjects such as "Infringement Suit Basic Training", and "Arbitration Representation Training"
   4) Continuing
      Theme: Continuing Subjects such as "Drafting of Complaint, Response and other Documents in Litigation against Trial Decision", and "Actual Practice of Contracts"
   5) Local
      Theme: Basically the Same as the General Course except held in Local Cities

Example II ("Infringement Suit Basic Training")

1) Lecturer: Yukio KOBYASHI, attorney at Law and Patent Attorney
   2) 5 Nights (3 Hours per Night)
   3) Themes:
      • Preparation for Infringement Suit and Its Negotiation
      • Preparation Just Before Commencement of Litigation
      • Procedures in Litigation
      • Closing of Litigation
      • Summary of IP Infringement Litigation
   4) Free Participation, No Test, Big Class
Compulsory Training Course

1) Under New Patent Attorney Law (70% Finished)
3) Object: To obtain knowledge on the Copyright Law, Unfair Competition Law, and Representation of Contract or Arbitration
4) Total 21 Times Starting from April 20, 2001 to December 5, 2002
5) Test to Confirm Attendee's Understanding

Example III ("3rd Tokyo Compulsory Training Course")

1) Dates: August 28 and 29, 2001
2) Place: MEIJI University Ochanomizu Campus
3) Subject and Lecture:
   - Copyright Law (Yumiko WASEDA, Attorney at Law)
     August 28/10:00~12:30, 13:30~16:00, 16:00~16:30(Test)
   - Representation of Contract or Arbitration (Takeshi KIKUCHI, Attorney at Law)
     August 29/10:00~12:00, 17:00~17:30(Test)
   - Unfair Competition Law (Toshiro MITSUSHI, Attorney at Law)
     August 29/14:00~17:00, 17:00~17:30(Test)
4) Textbooks are the Same in Every Course
5) Compulsory Training Course Certificate is issued
Aptitude Training Course

1) Conditions for Japanese patent attorneys handling IP Infringement Litigation
3) Object: To obtain knowledge on the Civil Law and the Civil Proceeding Act
4) Three steps:
   #1 Basic Course for members with engineering background
   #2 Aptitude Training Course
   #3 Test to confirm attendee’s understanding of laws
5) Time Schedule
   * Apr. 2002: Deliberation in the Diet
   * Summer 2002: #1 To be held at Universities
   * Spring 2003: #2 To be held
   * Summer 2003: #3 To be held

Ethics Training Course

1) Under new Patent Attorney Law
2) All registered Japanese Patent Attorneys Must Take the Course before May 25, 2004 and thereafter every 5 years
3) Object: To maintain ethical standards as a Patent Attorney
4) Theme:
   - Patent attorney discipline and professional duties
   - IIPA related matters
   - Business related matters
   - Office management related matters
   - Client related matters
5) 2 hours for each course starting from May 2002 in many cites
6) No test to confirm attendee’s understanding
Others

1) Technology Licensing Organization
2) IP Assist and Support Center
3) Patent Transaction Adviser
4) Information Retrieval Adviser

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